

# Tsu-Jae Liu

## List of Publications by Citations

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124  
papers

3,370  
citations

26  
h-index

55  
g-index

139  
ext. papers

4,077  
ext. citations

3.1  
avg. IF

5.24  
L-index

#	Paper	IF	Citations
124	Tunneling Field-Effect Transistors (TFETs) With Subthreshold Swing (SS) Less Than 60 mV/dec. <i>IEEE Electron Device Letters</i> , <b>2007</b> , 28, 743-745	4.4	1160
123	Demonstration of L-Shaped Tunnel Field-Effect Transistors. <i>IEEE Transactions on Electron Devices</i> , <b>2016</b> , 63, 1774-1778	2.9	161
122	Fully Integrated CMOS Power Amplifier With Efficiency Enhancement at Power Back-Off. <i>IEEE Journal of Solid-State Circuits</i> , <b>2008</b> , 43, 600-609	5.5	131
121	Tunnel Field Effect Transistor With Raised Germanium Source. <i>IEEE Electron Device Letters</i> , <b>2010</b> , 31, 1107-1109	4.4	113
120	Large-Scale SRAM Variability Characterization in 45 nm CMOS. <i>IEEE Journal of Solid-State Circuits</i> , <b>2009</b> , 44, 3174-3192	5.5	94
119	Study of Random Dopant Fluctuation Induced Variability in the Raised-Ge-Source TFET. <i>IEEE Electron Device Letters</i> , <b>2013</b> , 34, 184-186	4.4	92
118	Gate Line Edge Roughness Model for Estimation of FinFET Performance Variability. <i>IEEE Transactions on Electron Devices</i> , <b>2009</b> , 56, 3055-3063	2.9	70
117	Study of Random-Dopant-Fluctuation (RDF) Effects for the Trigate Bulk MOSFET. <i>IEEE Transactions on Electron Devices</i> , <b>2009</b> , 56, 1538-1542	2.9	66
116	Feedback FET: A novel transistor exhibiting steep switching behavior at low bias voltages <b>2008</b> ,		55
115	A Comparative Study of Dopant-Segregated Schottky and Raised Source/Drain Double-Gate MOSFETs. <i>IEEE Transactions on Electron Devices</i> , <b>2008</b> , 55, 2665-2677	2.9	50
114	Prospect of tunneling green transistor for 0.1V CMOS <b>2010</b> ,		47
113	Tri-Gate Bulk MOSFET Design for CMOS Scaling to the End of the Roadmap. <i>IEEE Electron Device Letters</i> , <b>2008</b> , 29, 491-493	4.4	45
112	SRAM Read/Write Margin Enhancements Using FinFETs. <i>IEEE Transactions on Very Large Scale Integration (VLSI) Systems</i> , <b>2010</b> , 18, 887-900	2.6	44
111	Characterization of Dynamic SRAM Stability in 45 nm CMOS. <i>IEEE Journal of Solid-State Circuits</i> , <b>2011</b> , 46, 2702-2712	5.5	42
110	Nano-Electro-Mechanical Nonvolatile Memory (NEMory) Cell Design and Scaling. <i>IEEE Transactions on Electron Devices</i> , <b>2008</b> , 55, 3482-3488	2.9	41
109	Mechanically modulated tunneling resistance in monolayer MoS <sub>2</sub> . <i>Applied Physics Letters</i> , <b>2013</b> , 103, 183105	3.4	36
108	Perfectly Complementary Relay Design for Digital Logic Applications. <i>IEEE Electron Device Letters</i> , <b>2010</b> , 31, 371-373	4.4	36

107	Characterization of Contact Resistance Stability in MEM Relays With Tungsten Electrodes. <i>Journal of Microelectromechanical Systems</i> , <b>2012</b> , 21, 511-513	2.5	36
106	Dopant-Segregated Schottky Source/Drain Double-Gate MOSFET Design in the Direct Source-to-Drain Tunneling Regime. <i>IEEE Transactions on Electron Devices</i> , <b>2009</b> , 56, 2016-2026	2.9	34
105	Effectiveness of Stressors in Aggressively Scaled FinFETs. <i>IEEE Transactions on Electron Devices</i> , <b>2012</b> , 59, 1592-1598	2.9	33
104	FinFET Evolution Toward Stacked-Nanowire FET for CMOS Technology Scaling. <i>IEEE Transactions on Electron Devices</i> , <b>2015</b> , 62, 3945-3950	2.9	31
103	Performance and Area Scaling Benefits of FD-SOI Technology for 6-T SRAM Cells at the 22-nm Node. <i>IEEE Transactions on Electron Devices</i> , <b>2010</b> , 57, 1301-1309	2.9	30
102	Germanium Gate PhotoMOSFET Integrated to Silicon Photonics. <i>IEEE Journal of Selected Topics in Quantum Electronics</i> , <b>2014</b> , 20, 1-7	3.8	29
101	Compact Nano-Electro-Mechanical Non-Volatile Memory (NEMory) for 3D Integration <b>2007</b> ,		29
100	Design Optimization of Multigate Bulk MOSFETs. <i>IEEE Transactions on Electron Devices</i> , <b>2013</b> , 60, 28-33	2.9	27
99	Adhesive Force Characterization for MEM Logic Relays With Sub-Micron Contacting Regions. <i>Journal of Microelectromechanical Systems</i> , <b>2014</b> , 23, 198-203	2.5	27
98	Hybrid CMOS/BEOL-NEMS technology for ultra-low-power IC applications <b>2014</b> ,		26
97	MOSFET design for forward body biasing scheme. <i>IEEE Electron Device Letters</i> , <b>2006</b> , 27, 387-389	4.4	26
96	Seesaw Relay Logic and Memory Circuits. <i>Journal of Microelectromechanical Systems</i> , <b>2010</b> , 19, 1012-1014	4.5	25
95	Impact of Body Doping and Thickness on the Performance of Germanium-Source TFETs. <i>IEEE Transactions on Electron Devices</i> , <b>2010</b> , 57, 1710-1713	2.9	25
94	ZrO <sub>2</sub> Ferroelectric FET for Non-volatile Memory Application. <i>IEEE Electron Device Letters</i> , <b>2019</b> , 40, 1419-1422	4.4	24
93	Characterization of Polycrystalline Silicon-Germanium Film Deposition for Modularly Integrated MEMS Applications. <i>Journal of Microelectromechanical Systems</i> , <b>2007</b> , 16, 68-77	2.5	21
92	Four-Terminal-Relay Body-Biasing Schemes for Complementary Logic Circuits. <i>IEEE Electron Device Letters</i> , <b>2010</b> , 31, 890-892	4.4	18
91	Carrier-Mobility Enhancement via Strain Engineering in Future Thin-Body MOSFETs. <i>IEEE Electron Device Letters</i> , <b>2012</b> , 33, 318-320	4.4	17
90	Design Requirements for Steeply Switching Logic Devices. <i>IEEE Transactions on Electron Devices</i> , <b>2012</b> , 59, 326-334	2.9	17

89	Spacer Gate Lithography for Reduced Variability Due to Line Edge Roughness. <i>IEEE Transactions on Semiconductor Manufacturing</i> , <b>2010</b> , 23, 311-315	2.6	17
88	Scaling Limitations for Flexural Beams Used in Electromechanical Devices. <i>IEEE Transactions on Electron Devices</i> , <b>2009</b> , 56, 688-691	2.9	16
87	Three-Dimensional FinFET Source/Drain and Contact Design Optimization Study. <i>IEEE Transactions on Electron Devices</i> , <b>2009</b> , 56, 1483-1492	2.9	16
86	Dopant-Segregated Schottky Junction Tuning With Fluorine Pre-Silicidation Ion Implant. <i>IEEE Transactions on Electron Devices</i> , <b>2010</b> , 57, 1084-1092	2.9	15
85	Planar GeOI TFET Performance Improvement With Back Biasing. <i>IEEE Transactions on Electron Devices</i> , <b>2012</b> , 59, 1629-1635	2.9	14
84	Comparative Study of Uniform Versus Supersteep Retrograde MOSFET Channel Doping and Implications for 6-T SRAM Yield. <i>IEEE Transactions on Electron Devices</i> , <b>2013</b> , 60, 1790-1793	2.9	14
83	Simulation-Based Study of Hybrid Fin/Planar LDMOS Design for FinFET-Based System-on-Chip Technology. <i>IEEE Transactions on Electron Devices</i> , <b>2017</b> , 64, 4193-4199	2.9	14
82	Simulation-Based Study of the Inserted-Oxide FinFET for Future Low-Power System-on-Chip Applications. <i>IEEE Electron Device Letters</i> , <b>2015</b> , 36, 742-744	4.4	14
81	Nanomechanical Switch Designs to Overcome the Surface Adhesion Energy Limit. <i>IEEE Electron Device Letters</i> , <b>2015</b> , 36, 963-965	4.4	14
80	Four-Terminal Relay Design for Improved Body Effect. <i>IEEE Electron Device Letters</i> , <b>2010</b> , 31, 515-517	4.4	14
79	Non-Volatile Nano-Electro-Mechanical Memory for Energy-Efficient Data Searching. <i>IEEE Electron Device Letters</i> , <b>2016</b> , 37, 31-34	4.4	13
78	Effect of Body Biasing on the Energy-Delay Performance of Logic Relays. <i>IEEE Electron Device Letters</i> , <b>2015</b> , 36, 862-864	4.4	13
77	Variation-Aware Comparative Study of 10-nm GAA Versus FinFET 6-T SRAM Performance and Yield. <i>IEEE Transactions on Electron Devices</i> , <b>2014</b> , 61, 3949-3954	2.9	13
76	A 1.2V, 2.4GHz Fully Integrated Linear CMOS Power Amplifier with Efficiency Enhancement <b>2006</b> ,		13
75	High-Mobility Ge pMOSFETs With Crystalline ZrO <sub>2</sub> Dielectric. <i>IEEE Electron Device Letters</i> , <b>2019</b> , 40, 371-374	4.4	12
74	Design of Gate-All-Around Silicon MOSFETs for 6-T SRAM Area Efficiency and Yield. <i>IEEE Transactions on Electron Devices</i> , <b>2014</b> , 61, 2371-2377	2.9	12
73	Electromechanical Diode Cell for Cross-Point Nonvolatile Memory Arrays. <i>IEEE Electron Device Letters</i> , <b>2012</b> , 33, 131-133	4.4	12
72	Multiple-Input Relay Design for More Compact Implementation of Digital Logic Circuits. <i>IEEE Electron Device Letters</i> , <b>2012</b> , 33, 281-283	4.4	12

71	Pull-In and Release Voltage Design for Nanoelectromechanical Field-Effect Transistors. <i>IEEE Transactions on Electron Devices</i> , <b>2009</b> , 56, 3072-3082	2.9	12
70	MOSFET hot-carrier reliability improvement by forward-body bias. <i>IEEE Electron Device Letters</i> , <b>2006</b> , 27, 605-608	4.4	12
69	Impact of back biasing on carrier transport in ultra-thin-body and BOX (UTBB) Fully Depleted SOI MOSFETs <b>2012</b> ,		11
68	Physically Based Modeling of Stress-Induced Variation in Nanoscale Transistor Performance. <i>IEEE Transactions on Device and Materials Reliability</i> , <b>2011</b> , 11, 378-386	1.6	11
67	Channel Stress and Ballistic Performance Advantages of Gate-All-Around FETs and Inserted-Oxide FinFETs. <i>IEEE Nanotechnology Magazine</i> , <b>2017</b> , 16, 209-216	2.6	10
66	Impact of Gate Line-Edge Roughness (LER) Versus Random Dopant Fluctuations (RDF) on Germanium-Source Tunnel FET Performance. <i>IEEE Nanotechnology Magazine</i> , <b>2013</b> , 12, 1061-1067	2.6	10
65	Multi-input/multi-output relay design for more compact and versatile implementation of digital logic with zero leakage <b>2012</b> ,		10
64	The Effect of Random Dopant Fluctuation on Specific Contact Resistivity. <i>IEEE Transactions on Electron Devices</i> , <b>2010</b> , 57, 273-281	2.9	10
63	A Novel Self-Aligned 4-Bit SONOS-Type Nonvolatile Memory Cell With T-Gate and I-Shaped FinFET Structure. <i>IEEE Transactions on Electron Devices</i> , <b>2010</b> , 57, 1728-1736	2.9	10
62	Nanocrystal-Embedded-Insulator Ferroelectric Negative Capacitance FETs With Sub-kT/q Swing. <i>IEEE Electron Device Letters</i> , <b>2018</b> , 1-1	4.4	10
61	Embedded Nano-Electro-Mechanical Memory for Energy-Efficient Reconfigurable Logic. <i>IEEE Electron Device Letters</i> , <b>2016</b> , 37, 1563-1565	4.4	9
60	Extension of Planar Bulk n-Channel MOSFET Scaling With Oxygen Insertion Technology. <i>IEEE Transactions on Electron Devices</i> , <b>2014</b> , 61, 3345-3349	2.9	9
59	Interfacial Adhesion between Rough Surfaces of Polycrystalline Silicon and Its Implications for M/NEMS Technology. <i>Journal of Adhesion Science and Technology</i> , <b>2010</b> , 24, 2545-2556	2	9
58	Scale-Length Assessment of the Trigate Bulk MOSFET Design. <i>IEEE Transactions on Electron Devices</i> , <b>2009</b> , 56, 2840-2842	2.9	9
57	Flicker-Noise Impact on Scaling of Mixed-Signal CMOS With HfSiON. <i>IEEE Transactions on Electron Devices</i> , <b>2008</b> , 55, 417-422	2.9	9
56	Impact of Gate-Induced Strain on MuGFET Reliability. <i>IEEE Electron Device Letters</i> , <b>2008</b> , 29, 916-919	4.4	9
55	Prospects for MEM logic switch technology <b>2010</b> ,		8
54	DSS MOSFET With Tunable SDE Regions by Fluorine Pre-Silicidation Ion Implant. <i>IEEE Electron Device Letters</i> , <b>2010</b> , 31, 785-787	4.4	8

53	Enhanced endurance of dual-bit SONOS NVM cells using the GIDL read method <b>2008</b> ,		8
52	Compensation of systematic variations through optimal biasing of SRAM wordlines <b>2008</b> ,		8
51	Energy-delay performance optimization of NEM logic relay <b>2015</b> ,		7
50	Large-scale read/write margin measurement in 45nm CMOS SRAM arrays <b>2008</b> ,		7
49	Variability Study for Low-Voltage Microelectromechanical Relay Operation. <i>IEEE Transactions on Electron Devices</i> , <b>2018</b> , 65, 1529-1534	2.9	6
48	Microelectromechanical Relay and Logic Circuit Design for Zero Crowbar Current. <i>IEEE Transactions on Electron Devices</i> , <b>2014</b> , 61, 3296-3302	2.9	6
47	NEM relay design for compact, ultra-low-power digital logic circuits <b>2014</b> ,		6
46	MOSFET performance and scalability enhancement by insertion of oxygen layers <b>2012</b> ,		6
45	Study of High-Performance Ge pMOSFET Scaling Accounting for Direct Source-to-Drain Tunneling. <i>IEEE Transactions on Electron Devices</i> , <b>2011</b> , 58, 2895-2902	2.9	6
44	Convex Channel Design for Improved Capacitorless DRAM Retention Time <b>2009</b> ,		6
43	Reliability of Nanoelectromechanical Nonvolatile Memory (NEMory) Cells. <i>IEEE Electron Device Letters</i> , <b>2009</b> , 30, 269-271	4.4	6
42	FinFET Design for Tolerance to Statistical Dopant Fluctuations. <i>IEEE Nanotechnology Magazine</i> , <b>2009</b> , 8, 375-378	2.6	6
41	Demonstration of 50-mV Digital Integrated Circuits with Microelectromechanical Relays <b>2018</b> ,		6
40	Threshold Voltage and DIBL Variability Modeling Based on Forward and Reverse Measurements for SRAM and Analog MOSFETs. <i>IEEE Transactions on Electron Devices</i> , <b>2015</b> , 62, 1119-1126	2.9	5
39	Tilted ion implantation as a cost-efficient sublithographic patterning technique. <i>Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics</i> , <b>2016</b> , 34, 040608	1.3	5
38	Recent progress and challenges for relay logic switch technology <b>2012</b> ,		5
37	Fabrication of $\text{Si}_{1-x}\text{Ge}_x/\text{Si}$ pMOSFETs Using Corrugated Substrates for Improved $I_{\text{ON}}$ and Reduced Layout-Width Dependence. <i>IEEE Transactions on Electron Devices</i> , <b>2013</b> , 60, 153-158	2.9	5
36	Dual-Bit Gate-Sidewall Storage FinFET NVM and New Method of Charge Detection. <i>IEEE Electron Device Letters</i> , <b>2007</b> , 28, 502-505	4.4	5

35	Reducing adhesion energy of nano-electro-mechanical relay contacts by self-assembled Perfluoro (2,3-Dimethylbutan-2-ol) coating. <i>AIP Advances</i> , <b>2019</b> , 9, 055329	1.5	4
34	Effects of oxygen-inserted layers on diffusion of boron, phosphorus, and arsenic in silicon for ultra-shallow junction formation. <i>Journal of Applied Physics</i> , <b>2018</b> , 123, 125704	2.5	4
33	Electromechanical Diode Cell Scaling for High-Density Nonvolatile Memory. <i>IEEE Transactions on Electron Devices</i> , <b>2014</b> , 61, 1382-1387	2.9	4
32	First Demonstration of Quasi-Planar Segmented-Channel MOSFET Design for Improved Scalability. <i>IEEE Transactions on Electron Devices</i> , <b>2012</b> , 59, 2273-2276	2.9	4
31	Variation Study and Implications for BJT-Based Thin-Body Capacitorless DRAM. <i>IEEE Electron Device Letters</i> , <b>2012</b> , 33, 312-314	4.4	4
30	MuGFET carrier mobility and velocity: Impacts of fin aspect ratio, orientation and stress <b>2010</b> ,		4
29	Tri-gate bulk MOSFET design for improved robustness to random dopant fluctuations <b>2008</b> ,		4
28	Impact of flash annealing on performance and reliability of high- $\kappa$ metal-gate MOSFETs for sub-45 nm CMOS <b>2007</b> ,		4
27	Sub-lithographic Patterning via Tilted Ion Implantation for Scaling Beyond the 7-nm Technology Node. <i>IEEE Transactions on Electron Devices</i> , <b>2017</b> , 64, 231-236	2.9	3
26	Rapid melt grown germanium gate photoMOSFET on a silicon waveguide <b>2013</b> ,		3
25	SRAM yield enhancement with thin-BOX FD-SOI <b>2009</b> ,		3
24	SRAM yield and performance enhancements with tri-gate bulk MOSFETs <b>2008</b> ,		3
23	Ultra-Low-Voltage Operation of MEM Relays for Cryogenic Logic Applications <b>2019</b> ,		3
22	Effects of oxygen-inserted layers and oxide capping layer on dopant activation for the formation of ultrashallow p-n junctions in silicon. <i>Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics</i> , <b>2018</b> , 36, 061211	1.3	3
21	Modeling Nanoelectromechanical Switches With Random Surface Roughness. <i>IEEE Transactions on Electron Devices</i> , <b>2017</b> , 64, 2409-2416	2.9	2
20	Simulation-Based Study of High-Density SRAM Voltage Scaling Enabled by Inserted-Oxide FinFET Technology. <i>IEEE Transactions on Electron Devices</i> , <b>2019</b> , 66, 1754-1759	2.9	2
19	Micro-relay reliability improvement by inkjet-printed microshell encapsulation <b>2013</b> ,		2
18	Inkjet-printed micro-electro-mechanical switches <b>2011</b> ,		2

17	Embedded Memory Capability of Four-Terminal Relay Technology. <i>IEEE Transactions on Electron Devices</i> , <b>2011</b> , 58, 891-894	2.9	2
16	SRAM design in fully-depleted SOI technology <b>2010</b> ,		2
15	Full 3D Simulation of 6T-SRAM Cells for the 22nm Node <b>2009</b> ,		2
14	Low-Standby-Power Bulk MOSFET Design Using High- $\kappa$ Trench Isolation. <i>IEEE Electron Device Letters</i> , <b>2009</b> , 30, 1380-1382	4.4	2
13	SRAM cell design considerations for SOI technology <b>2009</b> ,		2
12	Comparative Study of FinFET Versus Quasi-Planar HTI MOSFET for Ultimate Scalability. <i>IEEE Transactions on Electron Devices</i> , <b>2010</b> , 57, 3250-3256	2.9	2
11	Reducing adhesion energy of micro-relay electrodes by ion beam synthesized oxide nanolayers. <i>APL Materials</i> , <b>2017</b> , 5, 036103	5.7	1
10	Electrical Characterization of Etch Rate for Micro- and Nano-Scale Gap Formation. <i>Journal of Microelectromechanical Systems</i> , <b>2010</b> , 19, 1260-1263	2.5	1
9	Impact of random telegraph signals on $V_{min}$ in 45nm SRAM <b>2009</b> ,		1
8	WireFET Technology for 3-D Integrated Circuits <b>2006</b> ,		1
7	Cell Ratio Tuning for High-Density SRAM Voltage Scaling With Inserted-Oxide FinFETs. <i>IEEE Electron Device Letters</i> , <b>2016</b> , 37, 1539-1542	4.4	1
6	Design optimization of sub-5 nm node nanosheet field effect transistors to minimize self-heating effects. <i>Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics</i> , <b>2021</b> , 39, 013201	1.3	1
5	Simulation-Based Study of Si/Si <sub>0.9</sub> Ge <sub>0.1</sub> /Si Hetero-Channel FinFET for Enhanced Performance in Low-Power Applications. <i>IEEE Electron Device Letters</i> , <b>2019</b> , 40, 363-366	4.4	0
4	Defect Passivation by Selenium-Ion Implantation for Poly-Si Thin Film Transistors. <i>IEEE Electron Device Letters</i> , <b>2007</b> , 28, 725-727	4.4	0
3	Breakdown and Healing of Tungsten-Oxide Films on Microelectromechanical Relay Contacts. <i>Journal of Microelectromechanical Systems</i> , <b>2022</b> , 1-10	2.5	0
2	NEMS Switch Technology <b>2014</b> , 370-389		
1	Tuning of Schottky barrier height using oxygen-inserted (OI) layers and fluorine implantation. <i>AIP Advances</i> , <b>2020</b> , 10, 065310	1.5	